

US009450146B2

(12) United States Patent Jeong

(54) LIGHT-EMITTING DEVICE, LIGHT-EMITTING DEVICE PACKAGE, AND LIGHT UNIT

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(*) Notice: Subject to any disclaimer, the term of this

patent is extended or adjusted under 35

U.S.C. 154(b) by 0 days.

(21) Appl. No.: 14/405,473

(22) PCT Filed: May 24, 2013

(86) PCT No.: **PCT/KR2013/004575**

§ 371 (c)(1),

(2) Date: Dec. 4, 2014

(87) PCT Pub. No.: WO2013/183879

PCT Pub. Date: Dec. 12, 2013

(65) Prior Publication Data

US 2015/0187988 A1 Jul. 2, 2015

(30) Foreign Application Priority Data

Jun. 8, 2012 (KR) 10-2012-0061376

(51) Int. Cl.

H01L 33/00 H01L 33/10

(2010.01) (2010.01)

(Continued)

(52) U.S. Cl.

3/0418 (2013.01);

(Continued)

(10) Patent No.: US 9,450,146 B2

(45) **Date of Patent:**

Sep. 20, 2016

(58) Field of Classification Search

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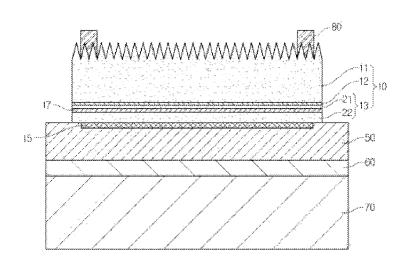
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(57) ABSTRACT

A light-emitting device, according to one embodiment, comprises: a light-emitting structure comprising a first conductive semiconductor layer, an active layer which is underneath the first conductive semiconductor layer which is underneath the active layer; a first electrode which is arranged under the light-emitting structure and is electrically connected to the second conductive semiconductor layer; a reflection layer which is arranged inside the second conductive semiconductor layer and arranged apart from the first electrode and the active layer; and a second electrode which is electrically connected to the first conductive semiconductor layer.

20 Claims, 8 Drawing Sheets



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FIG. 1

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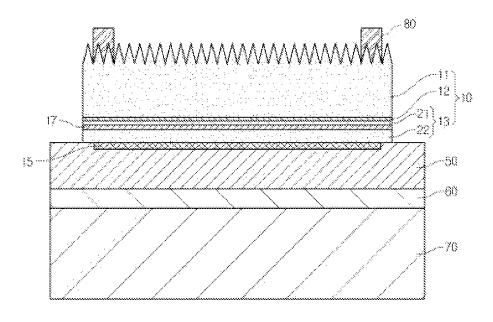


FIG. 2

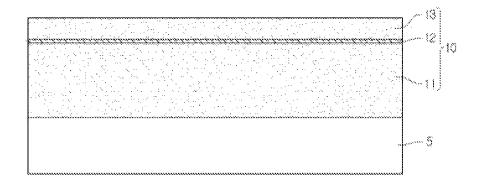


FIG. 3

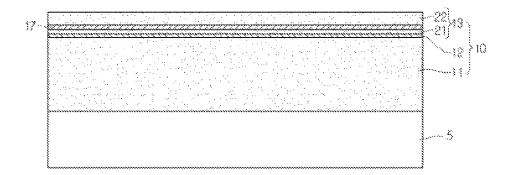


FIG. 4

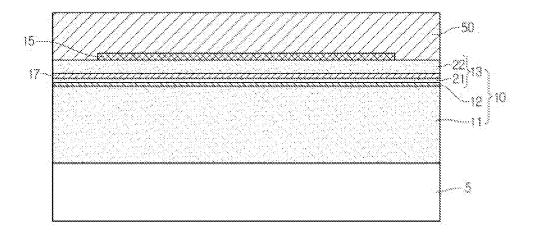


FIG. 5

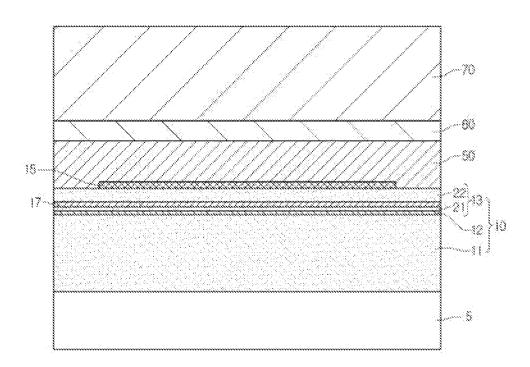


FIG. 6

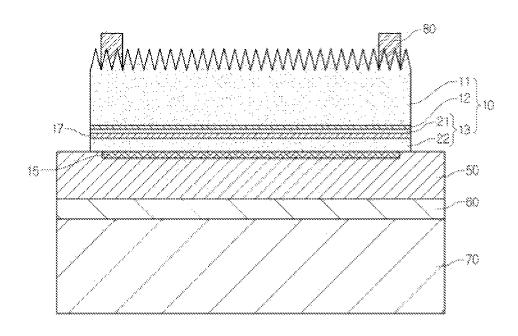


FIG. 7

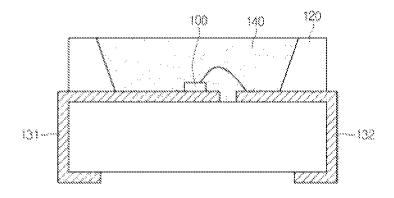


FIG. 8

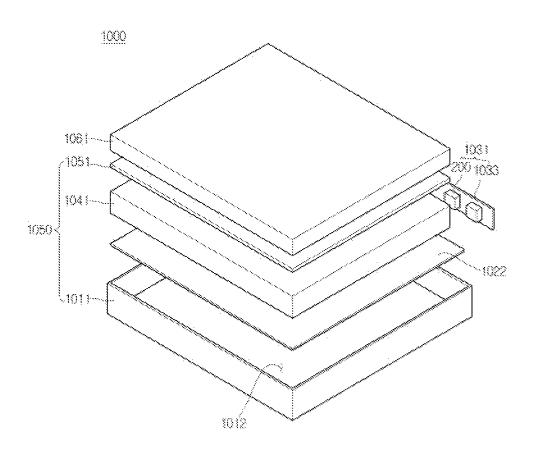


FIG. 9

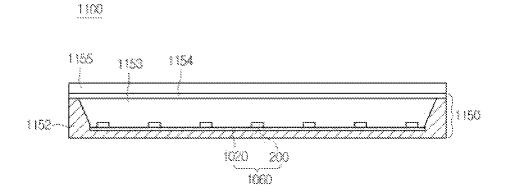


FIG. 10

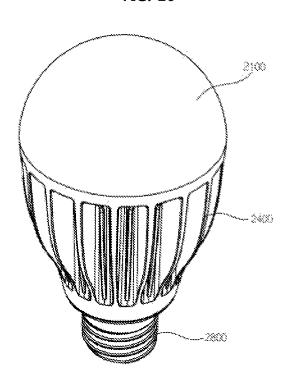


FIG.11

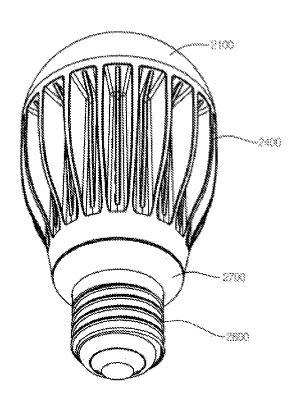


FIG. 12

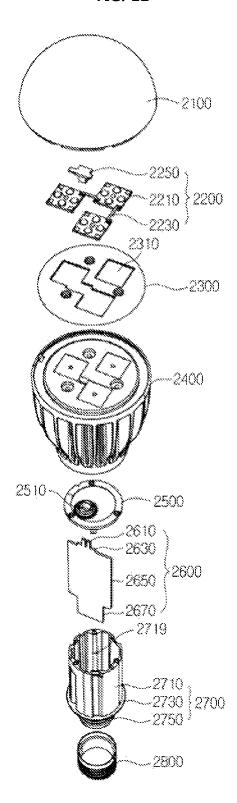


FIG. 13

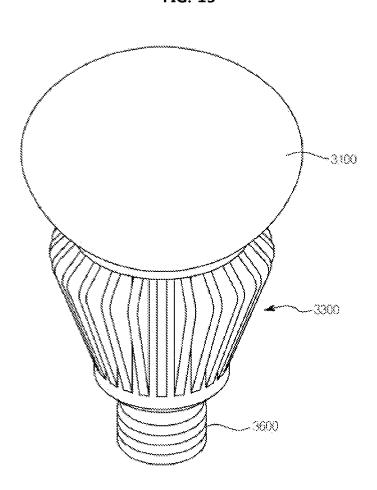
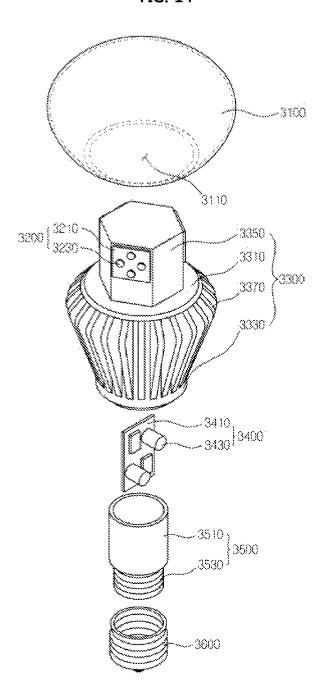


FIG. 14



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LIGHT-EMITTING DEVICE, LIGHT-EMITTING DEVICE PACKAGE, AND LIGHT UNIT

CROSS-REFERENCE TO RELATED PATENT APPLICATIONS

This application is a U.S National Stage Application under 35 U.S.C. §371 of PCT Application No. PCT/KR2013/004575, filed May 24, 2013, which claims priority to Korean Patent Application No. 10-2012-0061376, filed Jun. 8, 2012, whose entire disclosures are hereby incorporated by reference.

TECHNICAL FIELD

The embodiment relates to a light-emitting device, a light-emitting device package, and a light unit.

BACKGROUND ART

A light-emitting diode (LED) has been extensively used as one of light-emitting devices. The LED converts electrical signals into the form of light such as infra-red light, ultraviolet light, and visible light by using the characteristic of a 25 compound semiconductor.

As the light efficiency of the light-emitting device is increased, the LED has been used in various fields such as display apparatuses and lighting appliances.

DISCLOSURE

Technical Problem

The embodiment provides a light-emitting device, a light- semitting device package, and a light unit, capable of improving light extraction efficiency.

Technical Solution

A light-emitting device according to the embodiment includes a light-emitting structure including a first conductive semiconductor layer, an active layer under the first conductive semiconductor layer, and a second conductive semiconductor layer under the active layer; a first electrode 45 arranged under the light-emitting structure and electrically connected to the second conductive semiconductor layer; a reflective layer arranged inside the second conductive semiconductor layer and spaced apart from the first electrode and the active layer; and a second electrode electrically connected to the first conductive semiconductor layer.

A light-emitting device package according to the embodiment includes a body; a light-emitting device on the body; and first and second lead electrodes electrically connected to the light-emitting device, wherein the light-emitting device 55 includes a light-emitting structure including a first conductive semiconductor layer, an active layer under the first conductive semiconductor layer, and a second conductive semiconductor layer under the active layer; a first electrode arranged under the light-emitting structure and electrically 60 connected to the second conductive semiconductor layer; a reflective layer arranged inside the second conductive semiconductor layer and spaced apart from the first electrode and the active layer; and a second electrode electrically connected to the first conductive semiconductor layer.

A light unit according to the embodiment includes a substrate; a light-emitting device on the substrate; and an 2

optical member serving as an optical path for light emitted from the light-emitting device, wherein the light-emitting device includes a light-emitting structure including a first conductive semiconductor layer, an active layer under the first conductive semiconductor layer, and a second conductive semiconductor layer under the active layer; a first electrode arranged under the light-emitting structure and electrically connected to the second conductive semiconductor layer; a reflective layer arranged inside the second conductive semiconductor layer and spaced apart from the first electrode and the active layer; and a second electrode electrically connected to the first conductive semiconductor layer.

Advantageous Effects

The light-emitting device, the light-emitting device package, and the light unit according to the embodiment can improve the light extraction efficiency.

DESCRIPTION OF DRAWINGS

FIG. 1 is a view showing a light-emitting device according to the embodiment.

FIGS. 2 to 6 are views showing a method of fabricating a light-emitting device according to the embodiment.

FIG. 7 is a view showing a light-emitting device package according to the embodiment.

FIG. $\mathbf{8}$ is a view showing a display device according to the 30 embodiment.

FIG. 9 is a view showing another example of the display device according to the embodiment.

FIGS. 10 to 12 are views showing a lighting apparatus according to the embodiment.

FIGS. 13 and 14 are views showing another example of a lighting apparatus according to the embodiment.

BEST MODE

Mode for Invention

In the description of the embodiments, it will be understood that, when a layer (or film), a region, a pattern, or a structure is referred to as being on or "under" another substrate, another layer (or film), another region, another pad, or another pattern, it can be "directly" or "indirectly" over the other substrate, layer (or film), region, pad, or pattern, or one or more intervening layers may also be present. Such a position of the layer has been described with reference to the drawings.

The thickness and size of each layer shown in the drawings may be exaggerated, omitted or schematically drawn for the purpose of convenience or clarity. In addition, the size of elements does not utterly reflect an actual size.

Hereinafter, a light-emitting device, a light-emitting device package, a light unit, and a method for fabricating the light-emitting device according to the embodiments will be described in detail with reference to accompanying drawings.

FIG. 1 is a view showing a light-emitting device according to the embodiment.

As shown in FIG. 1, the light-emitting device according to the embodiment may include a light-emitting structure 10, a reflective layer 17, a first electrode 50 and a second electrode 80.

The light-emitting structure 10 may include a first conductive semiconductor layer 11, an active layer 12, and a

second conductive semiconductor layer 13. The active layer 12 may be interposed between the first conductive semiconductor layer 11 and the second conductive semiconductor layer 13. The active layer 12 may be provided under the first conductive semiconductor layer 11, and the second conduc- 5 tive semiconductor layer 13 may be provided under the active layer 12.

For instance, the first conductive semiconductor layer 11 may include an N-type semiconductor layer doped with N-type dopants serving as first conductive dopants, and the second conductive semiconductor layer 13 may include a P-type semiconductor layer doped with P-type dopants serving as second conductive dopants. In addition, the first conductive semiconductor layer 11 may include a P-type semiconductor layer, and the second conductive semiconductor layer 13 may include an N-type semiconductor layer.

For example, the first conductive semiconductor layer 11 may include an N-type semiconductor layer. The first conductive semiconductor layer 11 may be realized by using a compound semiconductor. The first conductive semiconduc- 20 tor layer 11 may be realized by using a group II-VI compound semiconductor, or a group III-V compound semicon-

For example, the first conductive semiconductor layer 11 may be realized by using a semiconductor material having a 25 compositional formula of $In_xAl_\nu Ga_{1-x-\nu}N$ ($0 \le x \le 1$, $0 \le y \le 1$, 0≤x+y≤1). For example, the first conductive semiconductor layer 11 may include one selected from the group consisting of GaN, AlN, AlGaN, InGaN, InN, InAlGaN, AlInN, AlGaAs, GaP, GaAs, GaAsP, and AlGaInP doped with 30 N-type dopants such as Si, Ge, Sn, Se, and Te.

The active layer 12 emits light having a wavelength corresponding to the energy band gap difference according to materials constituting the active layer 12 through the combination of electrons (or holes) injected through the first 35 conductive semiconductor layer 11 and holes (or electrons) injected through the second conductive semiconductor layer 13. The active layer 12 may have one of a single quantum well (SQW) structure, a multi-quantum well (MQW) structure, a quantum dot structure, and a quantum wire structure, 40 transparent conductive oxide layer. For example, the ohmic but the embodiment is not limited thereto.

The active layer 12 may be realized by using a compound semiconductor. The active layer 12 may be realized by using a semiconductor material having a compositional formula of InxAlyGa1-x-yN $(0 \le x \le 1, 0 \le y \le 1, 0 \le x+y \le 1)$. When the 45 active layer 12 has an MQW structure, the active layer 12 may be formed by stacking a plurality of well layers and a plurality of barrier layers. For example, the active layer 12 may have a cycle of InGaN well layer/GaN barrier layer.

For example, the second conductive semiconductor layer 50 13 may include a P-type semiconductor layer. The second conductive semiconductor layer 13 may be realized by using a compound semiconductor. For example, the second conductive semiconductor layer 13 may be realized by using a group II-VI compound semiconductor, or a group II-V 55 compound semiconductor.

For example, the second conductive semiconductor layer 13 may be realized by using a semiconductor material having a compositional formula of InxAlyGa1-x-yN $(0 \le x \le 1, 0 \le y \le 1, 0 \le x + y \le 1)$. For example, the second con- 60 ductive semiconductor layer 13 may include one selected from the group consisting of GaN, AlN, AlGaN, InGaN, InN, InAlGaN, AlInN, AlGaAs, GaP, GaAs, GaAsP, and AlGaInP doped with P-type dopants such as Mg, Zn, Ca, Sr, and Ba.

Meanwhile, the first conductive semiconductor layer 11 may include a P-type semiconductor layer and the second

conductive semiconductor layer 13 may include the N-type semiconductor layer. In addition, a semiconductor layer including an N-type or P-type semiconductor layer may be additionally provided under the second conductive semiconductor layer 13. Accordingly, the first light-emitting structure 10 may have at least one of an NP junction structure, a PN junction structure, an NPN junction structure, or a PNP junction structure. In addition, impurities may be doped into the first conductive semiconductor layer 11 and the second conductive semiconductor layer 13 with uniform or nonuniform doping concentration. In other words, the first light-emitting structure 10 may have various structures, and the embodiment is not limited thereto.

In addition, a first conductive InGaN/GaN superlattice structure or InGaN/InGaN superlattice structure may be formed between the first conductive semiconductor layer 11 and the active layer 12. In addition, a second conductive AlGaN layer may be formed between the second conductive semiconductor layer 13 and the active layer 12.

The first electrode 50 may be disposed under the lightemitting structure 10. The first electrode 50 may be electrically connected to the second conductive semiconductor layer 13. The first electrode 50 may make contact with a bottom surface of the second conductive semiconductor layer 13.

An ohmic contact layer 15 may be further disposed between the light-emitting structure 10 and the first electrode 50. A portion of the first electrode 50 may be disposed around the ohmic contact layer 15. A portion of the first electrode 50 may be disposed under the ohmic contact layer 15.

In addition, a first region of the first electrode 50 may make contact with a bottom of the second conductive semiconductor layer 13 and a second region of the first electrode 50 may extend outward from the first region of the first electrode **50**. The second region of the first electrode **50** may be exposed to a lower peripheral portion of the lightemitting structure 10.

For example, the ohmic contact layer 15 may include a contact layer 15 may include at least one selected from the group consisting of an ITO (Indium Tin Oxide), an IZO (Indium Zinc Oxide), an AZO (Aluminum Zinc Oxide), an AGZO (Aluminum Gallium Zinc Oxide), an IZTO (Indium Zinc Tin Oxide), an IAZO (Indium Aluminum Zinc Oxide), an IGZO (Indium Gallium Zinc Oxide), an IGTO (Indium Gallium Tin Oxide), an ATO (Antimony Tin Oxide), a GZO (Gallium Zinc Oxide), an IZON (IZO Nitride), ZnO, IrOx, RuOx, NiO, Pt and Ag.

The first electrode 50 may include at least one of Cu, Ni, Ti, Ti-W, Cr, W, Pt, V, Fe, and Mo. The first electrode 50 may serve as a diffusion barrier layer. A bonding layer 60 and a support member 70 may be disposed under the first electrode 50.

The first electrode 50 may prevent a material included in the bonding layer 60 from being diffused to the ohmic contact layer 15 in the process of providing the bonding layer 60. The first electrode 50 may prevent a material, such as Sn, included in the bonding layer 60 from exerting an influence upon the ohmic contact layer 15.

The bonding layer 60 may include barrier metal or bonding metal. For example, the bonding layer 60 may include at least one of Ti, Au, Sn, Ni, Cr, Ga, In, Bi, Cu, Ag, Nb, Pd and Ta. The support member 70 may support the light-emitting structure 10 according to the embodiment while performing a heat radiation function. The bonding layer 60 may be realized in the form of a seed layer.

The support member **70** may include at least one of semiconductor substrates (e.g., Si, Ge, GaN, GaAs, ZnO, SiC, and SiGe substrates) implanted with Ti, Cr, Ni, Al, Pt, Au, W, Cu, Mo, Cu—W, or impurities. For example, the support member **70** may be formed of insulating material.

The light-emitting device according to the embodiment may include a reflective layer 17 disposed in the second conductive semiconductor layer 13. The reflective layer 17 may be spaced apart from the first electrode 50. The reflective layer 17 may be spaced apart from the active layer 12.

The reflective layer 17 may have a thickness of 10 nm or more. For instance, the reflective layer 17 may have a thickness in the range of 10 nm to 100 nm. The reflective layer 17 may be sequentially grown when the second conductive semiconductor layer 13 is grown. In addition, the reflective layer 17 may be formed through an ion implantation process after the second conductive semiconductor layer 13 has been grown. For instance, the reflective layer 17 may include a conductive ion implantation layer. The reflective layer 17 may include one selected from the group consisting of Ag, Al, Pt and Rh.

The second conductive semiconductor layer 13 may be divided into a second conductive first semiconductor layer 21 and a second conductive second semiconductor layer 22 by the reflective layer 17. The second conductive first semiconductor layer 21 may be disposed on the reflective layer 17. The second conductive first semiconductor layer 21 may make contact with a top surface of the reflective layer 17. The second conductive second semiconductor layer 22 may be disposed under the reflective layer 17. The second conductive second semiconductor layer 22 may make contact with a bottom surface of the reflective layer 17.

The reflective layer 17 may be closer to the active layer 12 as compared with the first electrode 50. The second 35 conductive first semiconductor layer 21 may have a thickness thinner than a thickness of the second conductive second semiconductor layer 22. For instance, the reflective layer 17 may be disposed within 100 nm from the bottom surface of the active layer 12.

According to the embodiment, since the reflective layer 17 is closer to the active layer 12, the reflective layer 17 may effectively reflect light emitted from the active layer 12. In general, a semiconductor layer, such as the second conductive semiconductor layer 13, may have defects when the 45 crystal growth proceeds. Thus, the second conductive semiconductor layer 13 may absorb a part of light emitted from the active layer 12.

According to the embodiment, the reflective layer 17 is disposed adjacent to the active layer 12, so that the light 50 emitted from the active layer 12 may be effectively reflected by the reflective layer 17. Thus, according to the light-emitting device of the embodiment, light absorption in the second conductive semiconductor layer 13 may be reduced, so that the light extraction efficiency can be improved.

The reflective layer 17 may include a material having high reflectance. For example, the reflective layer 17 may include a metal including at least one of Ag, Ni, Al, Rh, Pd, Ir, Ru, Mg, Zn, Pt, Cu, Au, and Hf, or an alloy thereof. In addition, the reflective layer 17 may be formed in a multi-layer of the 60 metal or the alloy thereof and a transmissive conductive material such as an ITO (Indium-Tin-Oxide), an IZO (Indium-Zinc-Oxide), an IZTO (Indium-Zinc-Tin-Oxide), an IAZO (Indium-Aluminum-Zinc-Oxide), an IGZO (Indium-Gallium-Tin-Oxide), an AZO (Aluminum-Zinc-Oxide), or an ATO (Antimony-Tin-Oxide). For example, according to the

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embodiment, the reflective layer 17 may include at least one of Ag, Al, an Ag—Pd—Cu alloy, and an Ag—Cu alloy.

An additional layer, such as a diffusion barrier layer, may be formed on or under the reflective layer 17. The diffusion barrier layer formed on or under the reflective layer 17 may prevent materials contained in the reflective layer 17 from diffusing into the second conductive semiconductor layer 13

The light-emitting device according to the embodiment may include the second electrode 80 electrically connected to the first conductive semiconductor layer 11. For instance, the second electrode 80 may be disposed on the first conductive semiconductor layer 11. The second electrode 80 may make contact with a top surface of the first conductive semiconductor layer 11.

According to the embodiment, power may be applied to the light-emitting structure 10 through the first and second electrodes 50 and 80. According to the embodiment, the second electrode 80 may be realized in the form of a multiple layer. The second electrode 80 may include an ohmic layer, an intermediate layer, and an upper layer. The ohmic layer may include a material selected from the group consisting of Cr, V, W, Ti, and Zn to realize ohmic contact. The intermediate layer may be realized by using a material selected from the group consisting of Ni, Cu, and Al. For example, the upper layer may include Au. The second electrode 80 may include at least one selected from the group consisting of Cr, V, W, Ti, Zn, Ni, Cu, Al, and Au.

A light extraction pattern may be provided on the top surface of the light-emitting structure 10. A concavo-convex pattern may be provided on the top surface of the light-emitting structure 10. For example, the light extraction pattern provided on the light-emitting structure 10 may be formed through a PEC (photo electro chemical) etching process. Therefore, according to the embodiment, the light extraction effect to the outside can be increased.

Hereinafter, a method of fabricating the light-emitting device according to the embodiment will be described with reference to FIGS. 2 to 6.

According to the method of fabricating the light-emitting device of the embodiment, as shown in FIG. 2, the first conductive semiconductor layer 11, the active layer 12, and the second conductive semiconductor layer 13 may be formed on a substrate 5. The first conductive semiconductor layer 11, the active layer 12, and the second conductive semiconductor layer 13 may be defined as the light-emitting structure 10

For example, the substrate 5 may include at least one of a sapphire substrate (Al₂O₃), SiC, GaAs, GaN, ZnO, Si, GaP, InP, and Ge, but the embodiment is not limited thereto. A buffer layer may be interposed between the first conductive semiconductor layer 11 and the substrate 5.

For example, the first conductive semiconductor layer 11 may include an N-type semiconductor layer doped with N-type dopants serving as first conductive dopants, and the second conductive semiconductor layer 13 may include a P-type semiconductor layer doped with P-type dopants serving as second conductive dopants. In addition, the first conductive semiconductor layer 11 may include a P-type semiconductor layer, and the second conductive semiconductor layer. 13 may include an N-type semiconductor layer.

For example, the first conductive semiconductor layer 11 may include an N-type semiconductor. The first conductive semiconductor layer 11 may include a semiconductor material having a compositional formula of $In_xAl_yGa_{1-x-y}N$ ($0 \le x \le 1$, $0 \le y \le 1$, $0 \le x + y \le 1$). For example, the first conductive semiconductor layer 11a may include one selected from the

group consisting of InAlGaN, GaN, AlGaN, AlInN, InGaN, AlN, and InN, and may be doped with N-type dopants such as Si, Ge, Sn, Se, and Te.

The active layer 12 emits light having a wavelength corresponding to the energy band gap difference according 5 to materials constituting the active layer 12 through the combination of electrons (or holes) injected through the first conductive semiconductor layer 11 and holes (or electrons) injected through the second conductive semiconductor layer 13. The active layer 12 may have one of a single quantum well (SQW) structure, a multi-quantum well (MQW) structure, a quantum dot structure, and a quantum wire structure, but the embodiment is not limited thereto.

The active layer 12 may be realized by using a semiconductor material having a compositional formula of In_xA - 15 $I_yGa_{1-x-y}N$ ($0\le x\le 1$, $0\le y\le 1$, $0\le x+y\le 1$). When the active layer 12 has an MQW structure, the active layer 12 may be formed by stacking a plurality of well layers and a plurality of barrier layers. For example, the active layer 12 may have a cycle of InGaN well layer/GaN barrier layer.

For example, the second conductive semiconductor layer 13 may be realized by using a P type semiconductor. The second conductive semiconductor layer 13 may be realized by using a semiconductor material having a compositional formula of $In_xAl_yGa_{1.x-y}N$ ($0\le x\le 1$, $0\le y\le 1$, $0\le x+y\le 1$). For 25 example, the second conductive semiconductor layer 13 may include one selected from the group consisting of InAlGaN, GaN, AlGaN, InGaN, AlInN, AlN, and InN, and may be doped with P-type dopants such as Mg, Zn, Ca, Sr, and Ba

Meanwhile, the first conductive semiconductor layer 11 may include a P-type semiconductor layer and the second conductive semiconductor layer 13 may include the N-type semiconductor layer. In addition, a semiconductor layer including an N-type or P-type semiconductor layer may be 35 additionally provided on the second conductive semiconductor layer 13. Accordingly, the light-emitting structure 10 may have at least one of an NP junction structure, a PN junction structure, an NPN junction structure, or a PNP junction structure. In addition, impurities may be doped into 40 the first conductive semiconductor layer 11 and the second conductive semiconductor layer 13 with uniform or non-uniform doping concentration. In other words, the light-emitting structure 10 may have various structures, and the embodiment is not limited thereto.

In addition, the first conductive InGaN/GaN superlattice structure or InGaN/InGaN superlattice structure may be formed between the first conductive semiconductor layer 11 and the active layer 12. In addition, a second conductive AlGaN layer may be formed between the second conductive 50 semiconductor layer 13 and the active layer 12.

Next, as shown in FIG. 3, the reflective layer 17 may be formed in the second conductive semiconductor layer 13. For instance, the reflective layer 17 may be formed through an ion implantation process. The reflective layer 17 may 55 include a conductive ion implantation layer.

The reflective layer 17 may have a thickness of 10 nm or more. For instance, the reflective layer 17 may have a thickness in the range of 10 nm to 100 nm. The reflective layer 17 may include one selected from the group consisting 60 of Ag, Al, Pt and Rh.

The second conductive semiconductor layer 13 may be divided into a second conductive first semiconductor layer 21 and a second conductive second semiconductor layer 22 by the reflective layer 17. The second conductive first 65 semiconductor layer 21 may be disposed under the reflective layer 17. The second conductive first semiconductor layer 21

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may make contact with a bottom surface of the reflective layer 17. The second conductive second semiconductor layer 22 may be disposed on the reflective layer 17. The second conductive second semiconductor layer 22 may make contact with a top surface of the reflective layer 17.

Meanwhile, the reflective layer 17 may be sequentially grown when the second conductive semiconductor layer 13 is grown. In other words, the second conductive first semiconductor layer 21, the reflective layer 17 and the second conductive second semiconductor layer 22 may be sequentially formed.

In addition, as shown in FIG. 4, the ohmic contact layer 15 and the first electrode 50 may be formed on the light-emitting structure 10.

For example, the ohmic contact layer 15 may include a transparent conductive oxide layer. For example, the ohmic contact layer 15 may include at least one selected from the group consisting of an ITO (Indium Tin Oxide), an IZO (Indium Zinc Oxide), an AGZO (Aluminum Gallium Zinc Oxide), an IZTO (Indium Zinc Tin Oxide), an IAZO (Indium Aluminum Zinc Oxide), an IGZO (Indium Gallium Zinc Oxide), an IGTO (Indium Gallium Tin Oxide), an ATO (Antimony Tin Oxide), a GZO (Gallium Zinc Oxide), an IZON (IZO Nitride), ZnO, IrOx, RuOx, NiO, Pt and Ag.

The first electrode **50** may be electrically connected to the second conductive semiconductor layer **13**. The first electrode **50** may make contact with a top surface of the second conductive semiconductor layer **13**. A portion of the first electrode may be disposed around the ohmic contact layer **15**. A portion of the first electrode may be disposed on the ohmic contact layer **15**. The first electrode **50** may include at least one of Cu, Ni, TI, Ti—W, Cr, W, Pt, V, Fe, and Mo.

Then, as shown in FIG. 5, the bonding layer 60 and the support member 70 may be provided on the first electrode 50. The first electrode 50 may serve as a diffusion barrier layer. The first electrode 50 may prevent a material included in the bonding layer 60 from being diffused toward the ohmic contact layer 15 in the process of providing the bonding layer 60. The first electrode 50 may prevent a material, such as Sn, included in the bonding layer 60 from exerting an influence upon the ohmic contact layer 15.

The bonding layer 60 may include barrier metal or bonding metal. For example, the bonding layer 60 may include at least one of Ti, Au, Sn, Ni, Cr, Ga, In, Bi, Cu, Ag, Nb, Pd and Ta. The support member 70 may support the light-emitting structure 10 according to the embodiment while performing a heat radiation function. The bonding layer 60 may be realized in the form of a seed layer.

The support member 70 may include at least one of semiconductor substrates (e.g., Si, Ge, GaN, GaAs, ZnO, SiC, and SiGe substrates) implanted with Ti, Cr, Ni, Al, Pt, Au, W, Cu, Mo, Cu—W, or impurities.

Next, the substrate 5 is removed from the first conductive semiconductor layer 11. According to one example, the substrate 5 may be removed through a laser lift off (LLO) process. The LLO process is a process to delaminate the substrate 5 from the first conductive semiconductor layer 11 by irradiating a laser to the bottom surface of the substrate 5.

Then, as shown in FIG. 6, the lateral side of the light-emitting structure 10 is etched through an isolation etching process to expose a portion of the metal layer 30. The isolation etching process may be performed through a dry etching process such as an inductively coupled plasma (ICP) process, but the embodiment is not limited thereto.

In addition, as shown in FIG. 6, a light extraction pattern may be provided on the top surface of the light-emitting structure 10. A concavo-convex pattern may be provided on the top surface of the light-emitting structure 10. For example, the light extraction pattern provided on the light- 5 emitting structure 10 may be formed through a PEC (photo electro chemical) etching process. Therefore, according to the embodiment, the light extraction effect to the outside can be increased.

In addition, as shown in FIG. 6, the second electrode 80 10 electrically connected to the first conductive semiconductor layer 11 may be formed. For instance, the second electrode 80 may be disposed on the first conductive semiconductor layer 11. The second electrode 80 may make contact with a top surface of the first conductive semiconductor layer 11. 15

According to the embodiment, power may be applied to the light-emitting structure 10 through the first and second electrodes 50 and 80. According to the embodiment, the second electrode 80 may be realized in the form of a multiple layer. The second electrode 80 may include an 20 ohmic layer, an intermediate layer, and an upper layer. The ohmic layer may include a material selected from the group consisting of Cr, V, W, Ti, and Zn to realize ohmic contact. The intermediate layer may be realized by using a material selected from the group consisting of Ni, Cu, and Al. For 25 example, the upper layer may include Au. The second electrode 80 may include at least one selected from the group consisting of Cr, V, W, Ti, Zn, Ni, Cu, Al, and Au.

In addition, a first region of the first electrode 50 may make contact with a bottom of the second conductive 30 semiconductor layer 13 and a second region of the first electrode 50 may extend outward from the first region of the first electrode 50. The second region of the first electrode 50 may be exposed to a lower peripheral portion of the lightemitting structure 10.

The light-emitting device according to the embodiment may include the reflective layer 17 disposed in the second conductive semiconductor layer 13. The reflective layer 17 may be spaced apart from the first electrode 50. The reflective layer 17 may be spaced apart from the active layer 12. 40

The reflective layer 17 may be closer to the active layer 12 as compared with the first electrode 50. The second conductive first semiconductor layer 21 may have a thickness thinner than a thickness of the second conductive second semiconductor layer 22. For instance, the reflective 45 ting device 100 to protect the light-emitting device 100. In layer 17 may be disposed within 100 nm from the bottom surface of the active layer 12.

According to the embodiment, since the reflective layer 17 is closer to the active layer 12, the reflective layer 17 may effectively reflect light emitted from the active layer 12. In 50 general, a semiconductor layer, such as the second conductive semiconductor layer 13, may have defects when the crystal growth proceeds. Thus, the second conductive semiconductor layer 13 may absorb a part of light emitted from the active layer 12.

According to the embodiment, the reflective layer 17 is disposed adjacent to the active layer 12, so that the light emitted from the active layer 12 may be effectively reflected by the reflective layer 17. Thus, according to the lightemitting device of the embodiment, light absorption in the 60 second conductive semiconductor layer 13 may be reduced, so that the light extraction efficiency can be improved.

The reflective layer 17 may include a material having high reflectance. For example, the reflective layer 17 may include a metal including at least one of Ag, Ni, Al, Rh, Pd, Ir, Ru, 65 Mg, Zn, Pt, Cu, Au, and Hf, or an alloy thereof. In addition, the reflective layer 17 may be formed in a multi-layer of the

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metal or the alloy thereof and a transmissive conductive material such as an ITO (Indium-Tin-Oxide), an IZO (Indium-Zinc-Oxide), an IZTO (Indium-Zinc-Tin-Oxide), an IAZO (Indium-Aluminum-Zinc-Oxide), an IGZO (Indium-Gallium-Zinc-Oxide), an IGTO (Indium-Gallium-Tin-Oxide), an AZO (Aluminum-Zinc-Oxide), or an ATO (Antimony-Tin-Oxide). For example, according to the embodiment, the reflective layer 17 may include at least one of Ag, Al, an Ag-Pd-Cu alloy, and an Ag-Cu alloy.

An additional layer, such as a diffusion barrier layer, may be formed on or under the reflective layer 17. The diffusion barrier layer formed on or under the reflective layer 17 may prevent materials contained in the reflective layer 17 from diffusing into the second conductive semiconductor layer

FIG. 7 is a view showing a light-emitting device package to which the light-emitting device according to the embodiment is applied.

Referring to FIG. 7, the light-emitting device package according to the embodiment may include a body 120, first and second lead electrodes 131 and 132 formed on the body 120, a light-emitting device 100 provided on the body 120 and electrically connected to the first and second lead electrodes 131 and 132 and a molding member 140 that surrounds the light-emitting device 100.

The body 120 may include silicon, synthetic resin or metallic material, and an inclined surface may be formed in the vicinity of the light-emitting device 100.

The first and second lead electrodes 131 and 132 are electrically isolated from each other to supply power to the light-emitting device 100. The first and second lead electrode 131 and 132 can improve the light efficiency by reflecting the light emitted from the light-emitting device 100. Further, the first and second lead electrodes 131 and 132 may dissipate heat generated from the light-emitting device 100 to the outside.

The light-emitting device 100 can be installed on the body 120 or the first or second lead electrode 131 or 132.

The light-emitting device 100 may be electrically connected to the first and second lead electrodes 131 and 132 through one of a wire scheme, a flip-chip scheme, and a die-bonding scheme.

The molding member 140 may surround the light-emitaddition, the molding member 140 may include phosphors to change the wavelength of the light emitted from the light-emitting device 100.

A plurality of light-emitting device or light-emitting device packages according to the embodiment may be arrayed on a substrate, and an optical member including a lens, a light guide plate, a prism sheet, or a diffusion sheet may be provided on the optical path of the light emitted from the light-emitting device package. The light-emitting device 55 package, the substrate, and the optical member may serve as a light unit. The light unit is realized in a top view type or a side view type and variously provided in display devices of a portable terminal and a laptop computer or a lighting apparatus and an indicator apparatus. In addition, a lighting apparatus according to another embodiment can include a light-emitting device, or a light-emitting device package according to the embodiment. For example, the lighting apparatus may include a lamp, a signal lamp, an electric sign board and a headlight of a vehicle.

The light-emitting device according to the embodiment may be applied to the light unit. The light unit has a structure in which a plurality of light-emitting devices are arrayed.

The light unit may include a display device as shown in FIGS. **8** and **9** and the lighting apparatus as shown in FIGS. **10** to **14**.

Referring to FIG. **8**, a display device **1000** according to the embodiment includes a light guide plate **1041**, a lightemitting module **1031** for supplying the light to the light guide plate **1041**, a reflective member **1022** provided below the light guide plate **1041**, an optical sheet **1051** provided above the light guide plate **1041**, a display panel **1061** provided above the optical sheet **1051**, and a bottom cover **1011** for receiving the light guide plate **1041**, the lightemitting module **1031**, and the reflective member **1022**. However, the embodiment is not limited to the above structure.

The bottom cover 1011, the reflective member 1022, the 15 light guide plate 1041 and the optical sheet 1051 may constitute a light unit 1050.

The light guide plate 1041 diffuses the light to provide surface light. The light guide plate 1041 may include transparent material. For example, the light guide plate 1041 may 20 include one of acryl-based resin, such as PMMA (polymethyl methacrylate), PET (polyethylene terephthalate), PC (polycarbonate), COC (cyclic olefin copolymer) and PEN (polyethylene naphthalate) resin.

The light-emitting module 1031 supplies the light to at 25 least one side of the light guide plate 1041. The light-emitting module 1031 serves as the light source of the display device.

At least one light-emitting module 1031 is provided to directly or indirectly supply the light from one side of the 30 light guide plate 1041. The light-emitting module 1031 may include a substrate 1033 and light-emitting devices 100 or the light-emitting device package 200 according to the embodiment described above. The light-emitting packages 200 may be arrayed on the substrate 1033 while being 35 spaced apart from each other at the predetermined interval.

The substrate 1033 may be a printed circuit board (PCB) including a circuit pattern. In addition, the substrate 1033 may also include a metal core PCB (MCPCB) or a flexible PCB (FPCB) as well as the PCB, but the embodiment is not 40 limited thereto. If the light-emitting device packages 200 are installed on the lateral side of the bottom cover 1011 or on a heat dissipation plate, the substrate 1033 may be omitted. The heat dissipation plate may partially make contact with the top surface of the bottom cover 1011.

In addition, the light-emitting device packages 200 are installed such that light exit surfaces of the light-emitting device packages 200 are spaced apart from the light guide plate 1041 at a predetermined distance, but the embodiment is not limited thereto. The light-emitting device packages 50 200 may directly or indirectly supply the light to a light incident part, which is one side of the light guide plate 1041, but the embodiment is not limited thereto.

The reflective member 1022 may be disposed below the light guide plate 1041. The reflective member 1022 reflects 55 the light, which travels downward through the bottom surface of the light guide plate 1041, upward, thereby improving the brightness of the light unit 1050. For example, the reflective member 1022 may include PET, PC or PVC resin, but the embodiment is not limited thereto. The reflective 60 member 1022 may serve as the top surface of the bottom cover 1011, but the embodiment is not limited thereto.

The bottom cover 1011 may receive the light guide plate 1041, the light-emitting module 1031, and the reflective member 1022 therein. To this end, the bottom cover 1011 65 has a receiving section 1012 having a box shape with an opened top surface, but the embodiment is not limited

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thereto. The bottom cover 1011 can be coupled with the top cover (not shown), but the embodiment is not limited thereto.

The bottom cover 1011 can be manufactured through a press process or an extrusion process by using metallic material or resin material. In addition, the bottom cover 1011 may include metal or non-metallic material having superior thermal conductivity, but the embodiment is not limited thereto.

The display panel 1061, for example, is an LCD panel including first and second transparent substrates, which are opposite to each other, and a liquid crystal layer interposed between the first and second substrates. A polarizing plate can be attached to at least one surface of the display panel 1061, but the embodiment is not limited thereto. The display panel 1061 displays information by using light passing through the optical sheet 1051. The display device 1000 can be applied to various portable terminals, monitors of notebook computers and laptop computers, and televisions.

The optical sheet 1051 is disposed between the display panel 1061 and the light guide plate 1041 and includes at least one transmissive sheet. For example, the optical sheet 1051 includes at least one of a diffusion sheet, horizontal and vertical prism sheets, and a brightness enhanced sheet. The diffusion sheet diffuses the incident light, the horizontal and/or vertical prism sheet concentrates the incident light onto a display region, and the brightness enhanced sheet improves the brightness by reusing the light to be lost. In addition, a protective sheet can be provided on the display panel 1061, but the embodiment is not limited thereto.

The light guide plate 1041 and the optical sheet 1051 can be provided on the optical path of the light-emitting module 1031 as optical members, but the embodiment is not limited thereto.

FIG. 9 is a view showing another example of a display device according to the embodiment.

Referring to FIG. 9, the display device 1100 includes a bottom cover 1152, a substrate 1020 on which the light-emitting devices 100 are arrayed, an optical member 1154, and a display panel 1155.

The substrate 1020 and the light-emitting device packages 200 may constitute a light-emitting module 1060. The bottom cover 1152, at least one light-emitting module 1060, and the optical member 154 may constitute a light unit.

The bottom cover 1152 can be provided therein with a receiving section 1153, but the embodiment is not limited thereto.

In this case, the optical member 1154 may include at least one of a lens, a light guide plate, a diffusion sheet, horizontal and vertical prism sheets, and a brightness enhanced sheet. The light guide plate may include PC or PMMA (Poly methyl methacrylate). The light guide plate can be omitted. The diffusion sheet diffuses the incident light, the horizontal and vertical prism sheets concentrate the incident light onto a display region, and the brightness enhanced sheet improves the brightness by reusing the light to be lost.

The optical member 1154 is disposed above the lightemitting module 1060 in order to convert the light emitted from the light-emitting module 1060 into the surface light. In addition, the optical member 1154 may diffuse or collect the light.

FIGS. 10 to 12 are views showing a lighting apparatus according to the embodiment.

FIG. 10 is a top perspective view of the lighting apparatus, FIG. 11 is a bottom perspective view of the lighting apparatus shown in FIG. 10 and FIG. 12 is an exploded perspective view of the lighting apparatus shown in FIG. 10.

Referring to FIGS. 10 to 12, the lighting apparatus according to the embodiment may include a cover 2100, a light source module 2200, a radiator 2400, a power supply part 2600, an inner case 2700, and a socket 2800. The lighting apparatus according to the embodiment may further include at least one of a member 2300 and a holder 2500. The light source module 2200 may include the light-emitting device package according to the embodiment.

For example, the cover 2100 may have a bulb shape or a hemispheric shape. The cover 2100 may have a hollow structure which is partially open. The cover 2100 may be optically coupled with the light source module 2200. For example, the cover 2100 may diffuse, scatter, or excite light provided from the light source module 2200. The cover 2100 may be an optical member. The cover 2100 may be coupled with the radiator 2400. The cover 2100 may include a coupling part which is coupled with the radiator 2400.

The cover **2100** may include an inner surface coated with a milk-white pigment. The milk-white pigment may include 20 a diffusion material to diffuse light. The roughness of the inner surface of the cover **2100** may be greater than the roughness of the outer surface of the cover **2100**. The surface roughness is provided for the purpose of sufficiently scattering and diffusing the light from the light source module 25 **2200**.

The cover **2100** may include glass, plastic, polypropylene (PP), polyethylene (PE) or polycarbonate (PC). The polycarbonate (PC) has the superior light resistance, heat resistance and strength among the above materials. The cover **2100** may be transparent so that a user may view the light source module **2200** from the outside, or may be opaque. The cover **2100** may be formed through a blow molding scheme.

The light source module 220 may be disposed at one surface of the radiator 2400. Accordingly, the heat from the light source module 220 is transferred to the radiator 2400. The light source module 2200 may include a light source 2210, a connection plate 2230, and a connector 2250.

The member 2300 is disposed on a top surface of the radiator 2400, and includes guide grooves 2310 into which a plurality of light sources 2210 and the connector 2250 are inserted. The guide grooves 2310 correspond to a substrate of the light source 2210 and the connector 2250.

A surface of the member 2300 may be coated with a light reflective material. For example, the surface of the member 2300 may be coated with white pigment. The member 2300 reflects again light, which is reflected by the inner surface of the cover 2100 and is returned to the direction of the light 50 source module 2200, to the direction of the cover 2100. Accordingly, the light efficiency of the lighting apparatus according to the embodiment may be improved.

For example, the member 2300 may include an insulating material. The connection plate 2230 of the light source 55 module 2200 may include an electrically conductive material. Accordingly, the radiator 2400 may be electrically connected to the connection plate 2230. The member 2300 may be formed by an insulating material, thereby preventing the connection plate 2230 from being electrically shorted with the radiator 2400. The radiator 2400 receives heat from the light source module 2200 and the power supply part 2600 and dissipates the heat.

The holder 2500 covers a receiving groove 2719 of an insulating part 2710 of an inner case 2700. Accordingly, the 65 power supply part 2600 received in the insulating part 2710 of the inner case 2700 is sealed. The holder 2500 includes a

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guide protrusion 2510. The guide protrusion 2510 has a hole and a protrusion of the power supply part 2600 extends by passing through the hole.

The power supply part 2600 processes or converts an electric signal received from the outside and provides the processed or converted electric signal to the light source module 2200. The power supply part 2600 is received in the receiving groove 2719 of the inner case 2700, and is sealed inside the inner case 2700 by the holder 2500.

The power supply part 2600 may include a protrusion 2610, a guide part 2630, a base 2650, and an extension part 2670.

The guide part 2630 has a shape protruding from one side of the base 2650 to the outside. The guide part 2630 may be inserted into the holder 2500. A plurality of components may be disposed on one surface of the base 2650. For example, the components may include a DC converter to convert AC power provided from an external power supply into DC power, a driving chip to control the driving of the light source module 2200, and an electrostatic discharge (ESD) protection device to protect the light source module 2200, but the embodiment is not limited thereto.

The extension part 2670 has a shape protruding from an opposite side of the base 2650 to the outside. The extension part 2670 is inserted into an inside of the connection part 2750 of the inner case 2700, and receives an electric signal from the outside. For example, a width of the extension part 2670 may be smaller than or equal to a width of the connection part 2750 of the inner case 2700. First terminals of a "+ electric wire" and a "- electric wire" are electrically connected to the extension part 2670 and second terminals of the "+ electric wire" and the "- electric wire" may be electrically connected to a socket 2800.

The inner case 2700 may include a molding part therein together with the power supply part 2600. The molding part is prepared by hardening molding liquid, and the power supply part 2600 may be fixed inside the inner case 2700 by the molding part.

FIGS. 13 and 14 are views showing another example of a lighting apparatus according to the embodiment.

FIG. 13 is a perspective view of the lighting apparatus according to the embodiment and FIG. 14 is an exploded perspective view of the lighting apparatus shown in FIG. 13. In the following description about the lighting apparatus shown in FIGS. 13 and 14, components and structures the same as those described with reference to FIGS. 10 to 12 will not be further described in order to avoid redundancy.

Referring to FIGS. 13 and 14, the lighting apparatus according to the embodiment may include a cover 3100, a light source part 3200, a radiator 3300, a circuit part 3400, an inner case 3500, and a socket 3600. The light source part 3200 may include the light-emitting device or the light-emitting device module according to the embodiment.

For example, the member 2300 may include an insulating material. The connection plate 2230 of the light source 55 3100 has an opening 3110. The light source part 3200 and a module 2200 may include an electrically conductive material.

The cover 3100 may be coupled with the radiator 3300 and may surround the light source part 3200 and the member 3350. The light source part 3200 and the member 3350 may be blocked from the outside by the coupling between the cover 3100 and the radiator 3300. The cover 3100 may be coupled with the radiator 3300 by an adhesive or various schemes such as a rotation coupling scheme and a hook coupling scheme.

The rotation coupling scheme is a scheme where a thread of the cover 3100 is coupled with a screw groove of the radiator 3300, and the cover 3100 is coupled with the

radiator 3300 by rotation of the cover 3100. The hook coupling scheme is a scheme where a projection of the cover 3100 is inserted into a groove of the radiator 3300 so that the cover 3100 is coupled with the radiator 3300.

The light source part 3200 is disposed at the member 3350 5 of the radiator 3300, and a plurality of light source parts 3200 may be provided. In detail, the light source part 3200 may be disposed on at least one of side surfaces of the member 3350. In addition, the light source part 3200 may be disposed at an upper portion of the side surface of the 10 member 3350.

Referring to FIG. 14, the light source part 3200 may be disposed at three of six side surfaces of the member 3350. However, the embodiment is not limited thereto, and the light source part 3200 may be disposed at all side surfaces 15 of the member 3350. The light source part 3200 may include a substrate 3210 and a light-emitting device 3230. The light-emitting device 3230 may be disposed on one surface of the substrate 3210.

The substrate **3210** has a rectangular plate shape, but the 20 embodiment is not limited thereto. The substrate 3210 may have various shapes. For example, the substrate 3210 may have a circular plate shape or a polygonal plate shape. The substrate 3210 may be provided by printing a circuit pattern on an insulator. For example, the substrate 3210 may include 25 a typical printed circuit board (PCB), a metal core PCB, a flexible PCB, and a ceramic PCB. In addition, the substrate may have a COB (chips on board) type in which LED chips, which are not packaged, are directly bonded on the PCB. In addition, the substrate 3210 may include a material suitable 30 to reflect light, or the surface of the substrate may have a color such as a white color or a silver color to effectively reflect the light. The substrate 3210 may be electrically connected to the circuit part 3400 received in the radiator 3300. For example, the substrate 3210 and the circuit part 35 3400 may be connected to each other by a wire. The wire may connect the substrate 3210 and the circuit part 3400 to each other by passing through the radiator 3300.

The light-emitting device **3230** may include a luminescence material. The luminescence material may include at 40 least one of garnet-based phosphors (YAG, or TAG), silicate-based phosphors, nitride-based phosphors, and oxynitride-based phosphors. The luminescence material may include at least one of a red luminescence material, a yellow luminescence material and a green luminescence material. 45

The radiator 3300 is coupled with the cover 3100, and may radiate heat from the light source part 3200. The radiator 330 has a predetermined volume, and includes a top surface 3310 and a side surface 3330. The member 3350 may be disposed on the top surface 3310 of the radiator 50 3310. The top surface 3310 of the radiator 3300 may be coupled with the cover 3100. The top surface 3310 of the radiator 3300 may have a shape corresponding to an opening 3110 of the cover 3100.

A plurality of heat radiation pins 3370 may be disposed at 55 the side surface 3330 of the radiator 3300. The heat radiation pin 3370 may extend outward from the side surface 3330 of the radiator 3300 or may be connected to the side surface 3330 of the radiator 3300. The heat radiation pin 3370 may improve heat radiation efficiency by increasing a heat radiation area of the radiator 3300. The side surface 3330 may not include the heat radiation pin 3370.

The member 3350 may be disposed on the top surface of the radiator 3300. The member 3350 may be integrated with or coupled to the top surface 3310 of the radiator 3300. The 65 member 3350 may have the shape of a polygonal prism. In detail, the member 3350 may have the shape of a hexahedral

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prism. The member 3350 having the shape of a hexahedral prism includes a top surface, a bottom surface, and six side surfaces. The member 3350 may have the shape of a circular prism or the shape of an elliptical prism as well as the shape of a hexahedral prism. When the member 3350 has the shape of a circular prism or the shape of an elliptical prism, the substrate 3210 of the light source part 3200 may be a flexible substrate.

The light source part 3200 may be disposed at six side surfaces of the member 3350. The light source part 3200 may be disposed at all or some of the six side surfaces of the member 3350. The light source part 3200 is disposed at three of the six side surfaces of the member 3350.

The substrate 3210 is disposed at the side surface of the member 3350. The side surface of the member 3350 may be substantially vertical to the top surface 3310 of the radiator 3300. Accordingly, the substrate 3210 and the top surface of the radiator 3300 may be substantially vertical to each other.

The member 3350 may include a material representing thermal conductivity. Thus, heat from the light source part 3200 can be rapidly transferred to the member 3350. For example, the material for the member 3350 may include an alloy of metals such as aluminum (Al), nickel (Ni), copper (Cu), magnesium (Mg), silver (Ag), or tin (Sn). In addition, the member 3350 may include a plastic material having thermal conductivity. The plastic material having thermal conductivity is advantageous in that it is lighter than the metal and has thermal conductivity in a single direction.

The circuit part 3400 receives power from the outside, and converts the received power suitably for the light source part 3200. The circuit part 3400 provides the converted power to the light source part 3200. The circuit part 3400 may be disposed at the radiator 3300. In detail, the circuit part 3400 may be received in the inner case 3500, and may be received in the radiator 3300 together with the inner case 3500. The circuit part 3400 may include a circuit board 3410 and a plurality of components mounted on the circuit board 3410.

The circuit board **3410** has a circular shape, but the embodiment is not limited thereto. That is, the circuit board **3410** may have various shapes. For example, the circuit board may have an elliptical shape or a polygonal shape. The circuit board **3410** may be provided by printing a circuit pattern on an insulator.

The circuit board 3410 is electrically connected to the substrate 3210 of the light source part 3200. For example, the circuit part 3410 and the substrate 3210 may be connected to each other by a wire. The wire may be disposed inside the radiator 3300 to connect the substrate 3210 to the circuit board 3410. For example, a plurality of components 3430 may include a direct current converter converting AC power provided from an external power supply into DC power, a driving chip controlling driving of the light source part 3200, and an electrostatic discharge (ESD) protective device.

The inner case 3500 receives the circuit part 3400 therein. The inner case 3500 may include a receiving part 3510 to receive the circuit part 3400. For example, the receiving part 3510 may have a cylindrical shape. The shape of the receiving part 3510 may be changed according to the shape of the radiator 3300. The inner case 3500 may be received in the radiator 3300. The receiving part 3510 of the inner case 3500 may be received in a receiving part which is formed at a bottom surface of the radiator 3300.

The inner case 3500 may be coupled with the socket 3600. The inner case 3500 may include a connecting part 3530 coupled with the socket 3600. The connecting part 3530 may have a thread structure corresponding to a screw groove

structure of the socket 3600. The inner case 3500 is an insulator. Accordingly, the inner case 3500 prevents electric short between the circuit part 3400 and the radiator 3300. For example, the inner case 3500 may include a plastic or resin material.

The socket 3600 may be coupled with the inner case 3500. In detail, the socket 3600 may be coupled with the connecting part 3530 of the inner case 3500. The socket 3600 may have the structure the same as that of a conventional incandescent light bulb. The socket 3600 is electrically 10 connected to the circuit part 3400. For example, the circuit part 3400 and the socket 3600 may be connected to each other by a wire. If external power is applied to the socket 3600, the external power may be transferred to the circuit part 3400. The socket 3600 may have a screw groove 15 structure corresponding to a thread structure of the connecting part 3550.

Any reference in this specification to "one embodiment," "an embodiment," "example embodiment," etc., means that a particular feature, structure, or characteristic described in 20 connection with the embodiment is included in at least one embodiment of the invention. The appearances of such phrases in various places in the specification are not necessarily all referring to the same embodiment. Further, when a particular feature, structure, or characteristic is described in 25 connection with any embodiment, it is submitted that it is within the purview of one skilled in the art to affect such feature, structure, or characteristic in connection with other ones of the embodiments.

Although embodiments have been described with reference to a number of illustrative embodiments thereof, it should be understood that numerous other modifications and embodiments can be devised by those skilled in the art that will fall within the spirit and scope of the principles of this disclosure. More particularly, various variations and modifications are possible in the component parts and/or arrangements of the subject combination arrangement within the scope of the disclosure, the drawings and the appended claims. In addition to variations and modifications in the component parts and/or arrangements, alternative uses will 40 also be apparent to those skilled in the art.

The invention claimed is:

- 1. A light-emitting device comprising:
- a light-emitting structure including a first conductive semiconductor layer, an active layer under the first 45 conductive semiconductor layer, and a second conductive semiconductor layer under the active layer;
- a first electrode arranged under the light-emitting structure and electrically connected to the second conductive semiconductor layer;
- a reflective layer arranged inside the second conductive semiconductor layer and spaced apart from the first electrode and the active layer; and
- a second electrode electrically connected to the first conductive semiconductor layer,
- wherein the first electrode has a first region making contact with a bottom surface of the second conductive semiconductor layer and a second region extending outward from the first region, and
- wherein the second conductive semiconductor layer 60 includes a first semiconductor layer provided on the reflective layer and a second semiconductor layer provided under the reflective layer such that the reflective layer is provided between the first semiconductor layer and the second semiconductor layer, the first semiconductor layer and the second semiconductor layer being made of a same material.

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- 2. The light-emitting device of claim 1, wherein the reflective layer includes a conductive ion implantation layer.
- 3. The light-emitting device of claim 1, wherein the reflective layer includes at least one of Ag, Al, Pt and Rh.
- **4**. The light-emitting device of claim **1**, further including an ohmic contact layer between the first electrode and the second conductive semiconductor layer.
- 5. The light-emitting device of claim 1, wherein the second region of the first electrode is exposed to a lower peripheral portion of the light-emitting structure.
- **6**. The light-emitting device of claim **1**, further including a bonding layer and a support member under the first electrode.
- 7. A light unit including the light emitting device of claim 1, the light unit comprising:
 - a substrate;
 - a light-emitting device on the substrate; and
 - an optical member serving as an optical path for light emitted from the light-emitting device.
- 8. The light-emitting device of claim 1, wherein a bottom most surface of the first semiconductor layer is provided on a top surface of the reflective layer and a top most surface of the second semiconductor layer is provided under the reflective layer.
- **9**. The light-emitting device of claim **1**, wherein the first semiconductor layer is not in contact with the second semiconductor layer.
- 10. The light-emitting device of claim 1, wherein a total lateral width of the first semiconductor layer is substantially a same width as a total lateral width of the reflective layer.
 - 11. A light-emitting device package comprising: a body:
 - a light-emitting device on the body; and
 - first and second lead electrodes electrically connected to the light-emitting device,
 - wherein the light-emitting device comprises a light-emitting structure including a first conductive semiconductor layer, an active layer under the first conductive semiconductor layer, and a second conductive semiconductor layer under the active layer; a first electrode arranged under the light-emitting structure and electrically connected to the second conductive semiconductor layer; a reflective layer arranged inside the second conductive semiconductive semiconductor layer and spaced apart from the first electrode and the active layer; and a second electrode electrically connected to the first conductive semiconductor layer,
 - wherein the first electrode has a first region making contact with a bottom surface of the second conductive semiconductor layer and a second region extending outward from the first region,
 - wherein a first distance between the reflective layer and the active layer is less than a second distance between the reflective layer and the first electrode, and
 - wherein the second conductive semiconductor layer includes a first semiconductor layer provided on the reflective layer and a second semiconductor layer provided under the reflective layer such that the reflective layer is provided between the first semiconductor layer and the second semiconductor layer, the first semiconductor layer and the second semiconductor layer being made of a same material.
- 12. The light-emitting device package of claim 11, wherein the reflective layer includes a conductive ion implantation layer.

- 13. The light-emitting device package of claim 11, wherein the reflective layer has a thickness in a range of 10 nm to 100 nm.
- **14**. The light-emitting device package of claim **11**, wherein the reflective layer is closer to the active layer as 5 compared with the first electrode.
- 15. The light-emitting device package of claim 11, wherein the reflective layer is provided within 100 nm from a bottom surface of the active layer.
- **16**. The light-emitting device package of claim **11**, 10 wherein the reflective layer includes at least one of Ag, Al, Pt and Rh.
- 17. The light-emitting device package of claim 11, wherein a top surface of the reflective layer is not exposed.
- 18. The light-emitting device package of claim 11, 15 wherein a bottom most surface of the first semiconductor layer is provided on a top surface of the reflective layer and a top most surface of the second semiconductor layer is provided under the reflective layer.
- **19**. The light-emitting device package of claim **11**, 20 wherein the first semiconductor layer is not in contact with the second semiconductor layer.
- **20**. The light-emitting device package of claim **11**, wherein a total lateral width of the first semiconductor layer is substantially a same width as a total lateral width of the 25 reflective layer.

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